



10/809,070

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

re patent or patent applications of:

| Inventor           | Serial or<br>Patent No. | Filing or<br>Issue Date | Title   | Atty.<br>Docket No. |
|--------------------|-------------------------|-------------------------|---|---------------------|
| Haibara et al.     | 10/975,617              | 10/28/2004              | Method for Forwarding Ozonated Water  | WSAG 0125 PUS       |
| Haibara et al.     | 10/975,510              | 10/28/2004              | Method For Supply Of Constant-<br>Concentration Ozonated Water  | WSAG 0126 PUS       |
| VonAmmon<br>et al. | 10/809,070              | 03/25/2004              | Method and Device For The Production<br>Of A Silicon Single Crystal, Silicon<br>Single Crystal, and Silicon<br>Semiconductor Wafers With Determined<br>Defect Distributions | WSAG 0143 PUS       |

**REVOCATION OF PREVIOUS POWER  
OF ATTORNEY (37 C.F.R. § 1.36) AND  
NEW POWER OF ATTORNEY (37 C.F.R. § 1.32)**

Commissioner for Patents  
U.S. Patent & Trademark Office  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Siltronic AG is the Assignee of the entire right, title and interest of the patent applications as presented below. Attached is a Statement Under 37 C.F.R. § 3.73(b) Establishing Right of Assignee to Take Action in this application.

| Serial or<br>Patent No. | Filing or<br>Issue Date | Atty.<br>Docket No. |
|-------------------------|-------------------------|---------------------|
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